



UNITED STATES PATENT and TRADEMARK OFFICE

UNDER SECRETARY OF COMMERCE FOR INTELLECTUAL PROPERTY AND  
DIRECTOR OF THE UNITED STATES PATENT AND TRADEMARK OFFICE  
WASHINGTON, D.C. 20231  
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MAR - 4 2003

#10

In re Application of :  
Yoshihiko Okamoto, et al :  
Serial No. 09/922,656 :  
Filed: August 07, 2001 :  
For: PROCESS FOR FABRICATING SEMI- :  
CONDUCTOR INTEGRATED CIRCUIT DEVICE, :  
AND EXPOSING SYSTEM AND MASK INSPEC- :  
TING METHOD TO BE USED IN THE PROCEDSS:

NOTICE OF WITHDRAWAL  
FROM ISSUE  
UNDER 37 CFR 1.313(b)

The above-identified application is withdrawn from issue after payment of the issue fee due to reopening of prosecution. See 37 CFR 1.313 (b).

The above-identified application is hereby withdrawn from issue.

The issue fee is refundable upon written request. If, however, the application is again found allowable, the issue fee can be applied toward payment of the issue fee in the amount identified on the new Notice of Allowance and Issue Fee Due upon written request. This request and any balance due must be received on or before the due date noted in the new Notice of Allowance in order to prevent abandonment of the application.

Telephone inquiries should be directed to Mark Huff at (703) 308-2464.

The above-identified application is being forwarded to the examiner for prompt appropriate action, including notifying applicant of the new status of this application.



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Cc: Allowed Files—Pk3-915